

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q92709

Masahiko ISHIDA, et al.

Application No.: 10/564,750

Group Art Unit: 1792

Confirmation No.: 1790

Examiner: Felisa Carla HITESHEW

Filed: January 17, 2006

For: METHOD FOR FIXING METAL PARTICLES AND METHOD FOR MANUFACTURING  
SUBSTRATE CONTAINING METAL PARTICLES, METHOD FOR MANUFACTURING  
SUBSTRATE CONTAINING CARBON NANOTUBE, AND METHOD FOR  
MANUFACTURING SUBSTRATE CONTAINING SEMICONDUCTOR-CRYSTALLINE ROD,  
EMPLOYING

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicants hereby petition for an extension of time of one month, extending the time for responding to the Office Action of September 24, 2008 from December 24, 2008 to January 24, 2009.

The USPTO is directed and authorized to charge the statutory fee of \$130.00 and all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

  
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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: January 23, 2009